

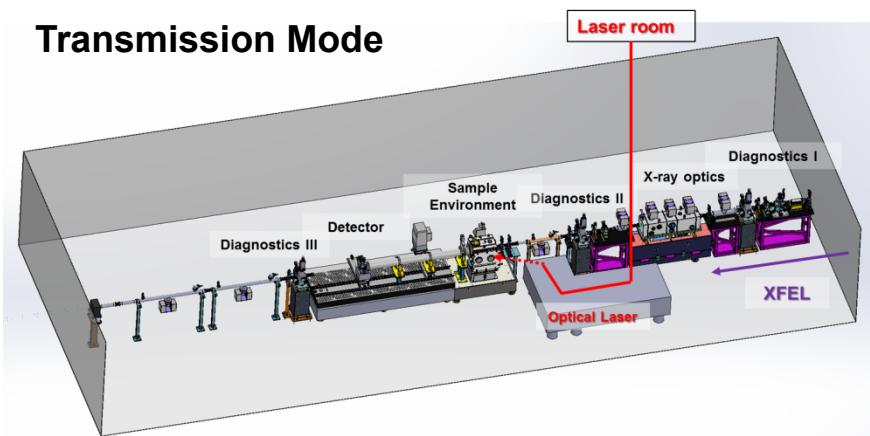
# **First experiments – SFX & operation schemes**

**Jaehyun Park & Ki-Hyun Nam**

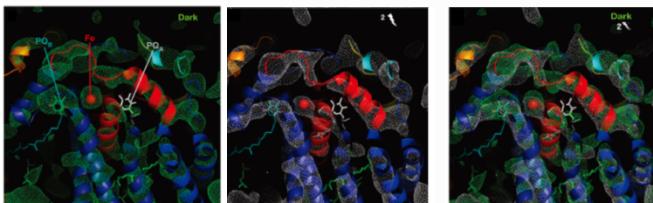
# Nano Crystallography & Imaging (NCI) station



## Transmission Mode

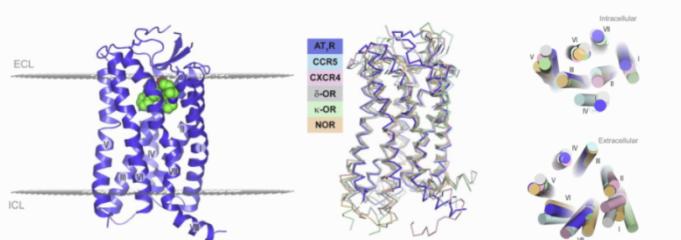


## Serial Femtosecond Crystallography



Structure of the PSII

Kupitz et al. *Nature*. (2014)



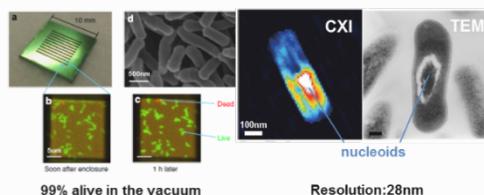
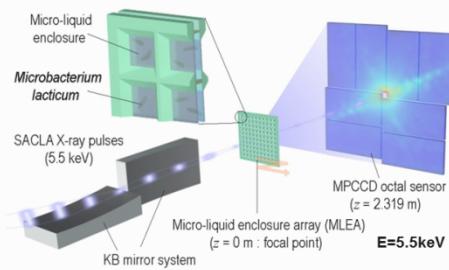
Structure of the Angiotensin Receptor

Zhang et al. *Cell* (2015)

## NCI Experiments:

- Serial femtosecond crystallography (SFX)
- Time-resolved SFX
- Coherent diffraction imaging (CDI)
- Single-pulse nano-particle imaging
- Single-pulse bio-imaging
- Ultrafast time-resolved imaging

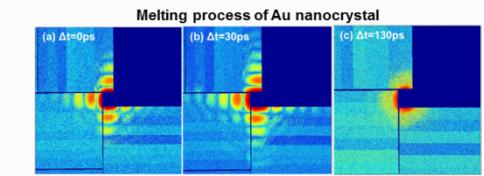
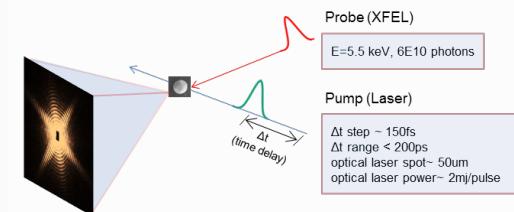
## Single-pulse Bio-imaging



Living cell (lacticum) Imaging

Takashi. et al., *Nature comm.* (2014)

## Time-resolved Imaging



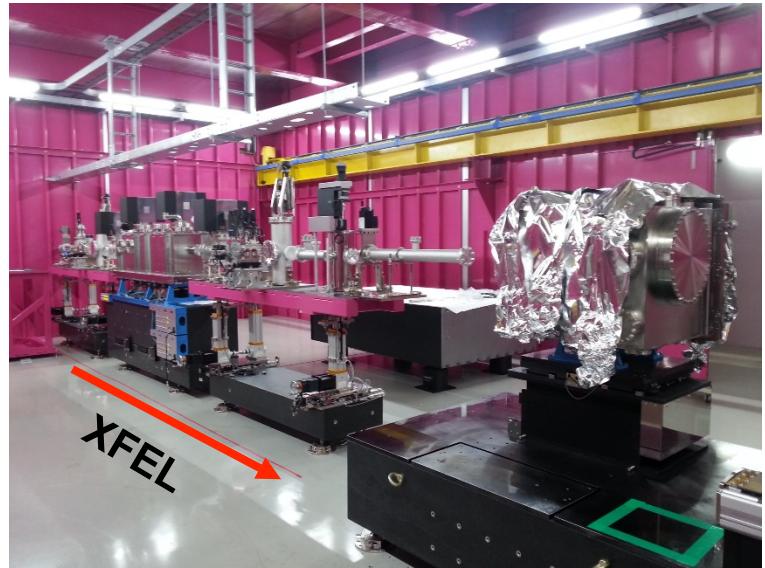
Dr. Song et al., Postech Physics

# NCI Layout

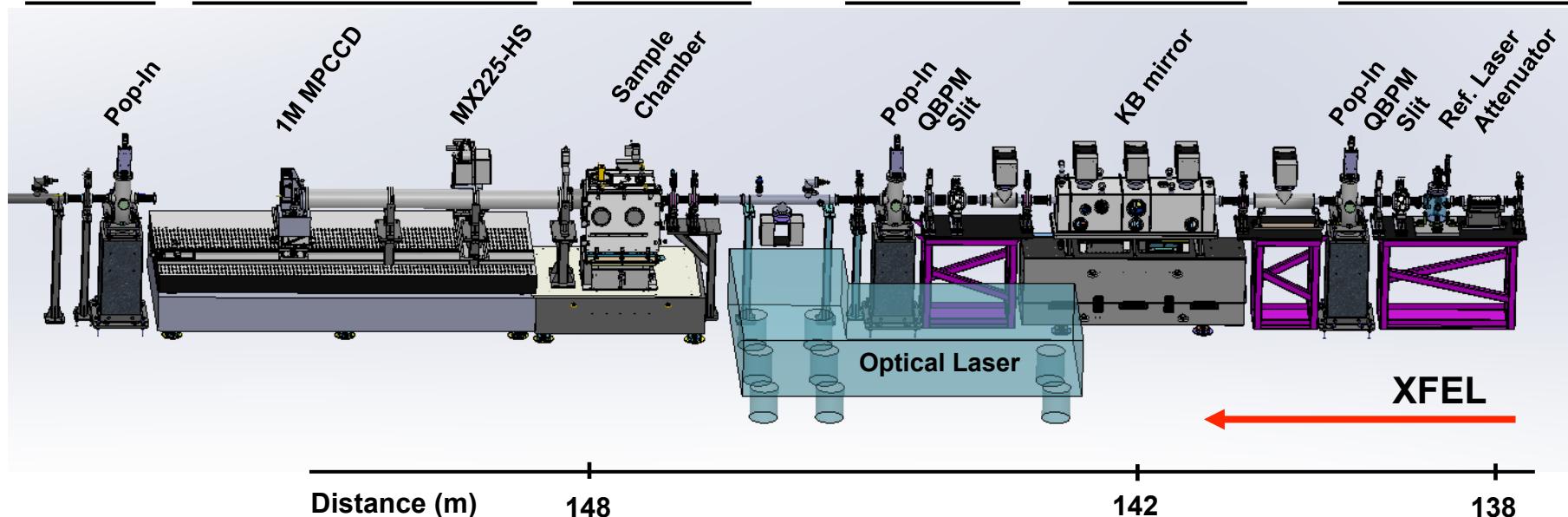


## Experimental station spec

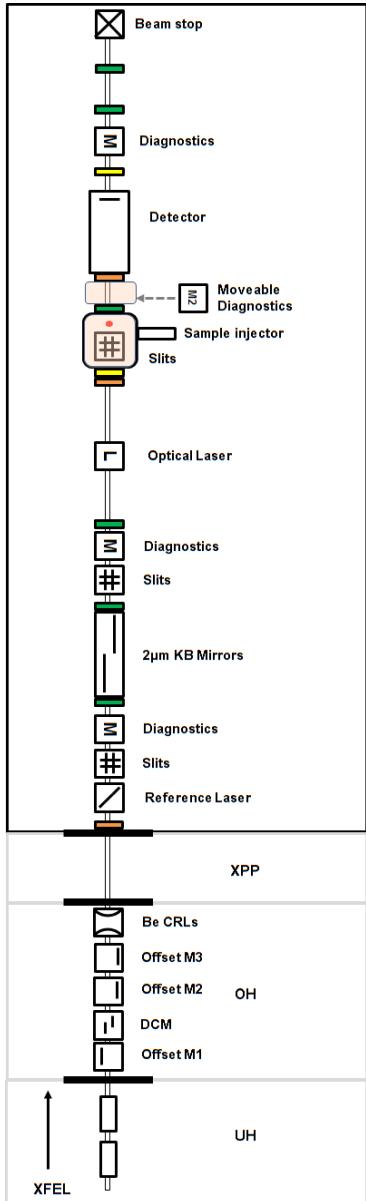
|                    |  |
|--------------------|--|
| Energy Range       | 2-20 keV<br>5-12 keV (Optimized)   |
| Beam Size          | 1500 $\mu\text{m}$ (Unfocused beam) @12.4 keV<br>2 $\mu\text{m}$ (KB mirror) @12.4 keV       |
| Sample Environment | High Vacuum ( $\sim 10^{-7}$ Torr)<br>He ambience<br>Fixed target , Liquid and LCP injectors |
| Detector           | 1M MPCCD (50 x 50 $\mu\text{m}^2$ pixels size)<br>MX225-HS (Rayonix)                         |



Diagnostics III      Detector stage      Sample      Diagnostics II      Focusing optics      Diagnostics I



# X-ray optics: Kirkpatrick-Baez Mirror



## ➤ Purpose

- Increases photon flux at interaction point

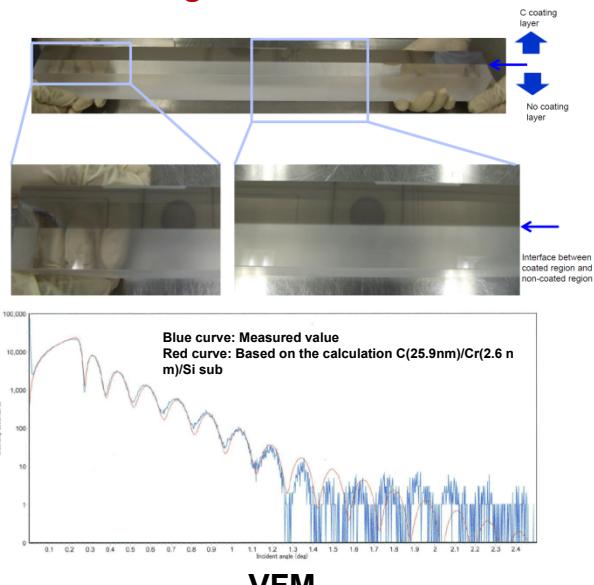
## ➤ Requirements

- Beam size: 2 μm
- Focal length: 5.68 m (center of mirrors)
- Reflectivity: >99% (at 5 ~ 12. 4 keV)
- Mirror length: accept 4 σ or more
- Vacuum environment: <10<sup>-8</sup> Torr

## ➤ Production

- Mirror substrate: JTEC (Japan)
- Mirror coating: NTT-AT (Japan)

## ➤ Mirror coating



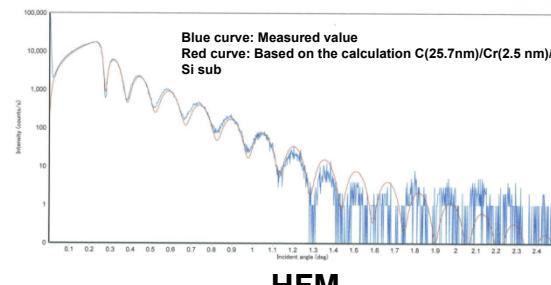
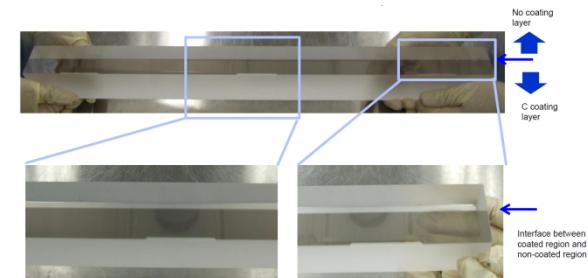
## ➤ Substrate inspection

Table2-1: First Mirror (VFM)

|   |                        | Unit     | Specification      | Measurement | Judgment |
|---|------------------------|----------|--------------------|-------------|----------|
| 1 | Substrate size         | mm       | 600 ± 0.5          | 599.99      | OK       |
|   | Width                  | mm       | 50 ± 0.2           | 49.99       | OK       |
|   | Thickness              | mm       | 50 ± 0.2           | 50.15       | OK       |
| 2 | Material               | —        | Quartz             | —           | —        |
| 3 | Shape                  | —        | Tangential ellipse | —           | —        |
| 4 | Useful area            | mm       | >580               | 588.20      | OK       |
|   |                        | mm       | >20                | 22.00       | OK       |
| 5 | Tangential Slope error | μrad rms | <0.1               | 0.096       | OK       |
| 6 | Sagittal Slope error   | μrad rms | <2.0               | 0.171       | OK       |
| 7 | Roughness (50X)        | nm rms   | <0.3               | 0.175       | OK       |

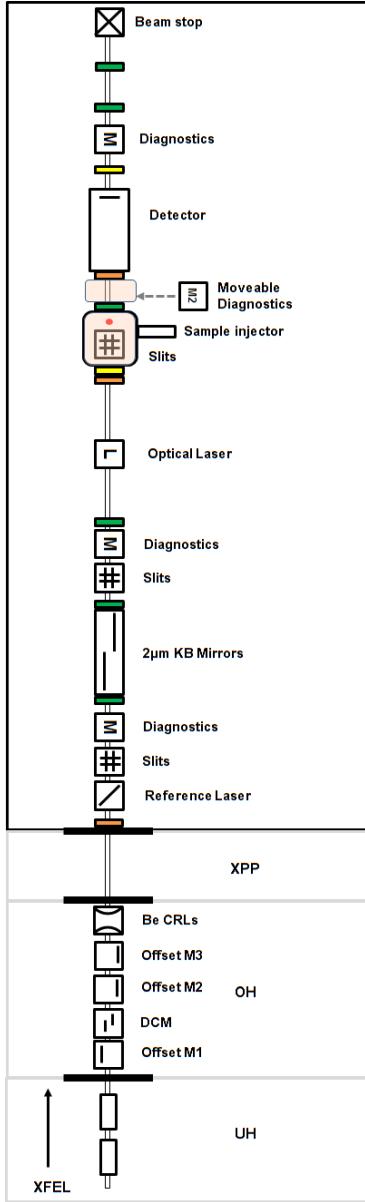
Table2-2: Second Mirror (HFM)

|   |                        | Unit     | Specification      | Measurement | Judgment |
|---|------------------------|----------|--------------------|-------------|----------|
| 1 | Substrate size         | mm       | 600 ± 0.5          | 600.00      | OK       |
|   | Width                  | mm       | 50 ± 0.2           | 50.00       | OK       |
|   | Thickness              | mm       | 50 ± 0.2           | 50.09       | OK       |
| 2 | Material               | —        | Quartz             | —           | —        |
| 3 | Shape                  | —        | Tangential ellipse | —           | —        |
| 4 | Useful area            | mm       | >580               | 580.50      | OK       |
|   |                        | mm       | >20                | 20.50       | OK       |
| 5 | Tangential Slope error | μrad rms | <0.1               | 0.092       | OK       |
| 6 | Sagittal Slope error   | μrad rms | <2.0               | 0.278       | OK       |
| 7 | Roughness (50X)        | nm rms   | <0.3               | 0.168       | OK       |



HFM

# X-ray optics: Mirror manipulator



## ➤ Purpose

- Alignment of two KB focusing mirrors

## ➤ Requirements

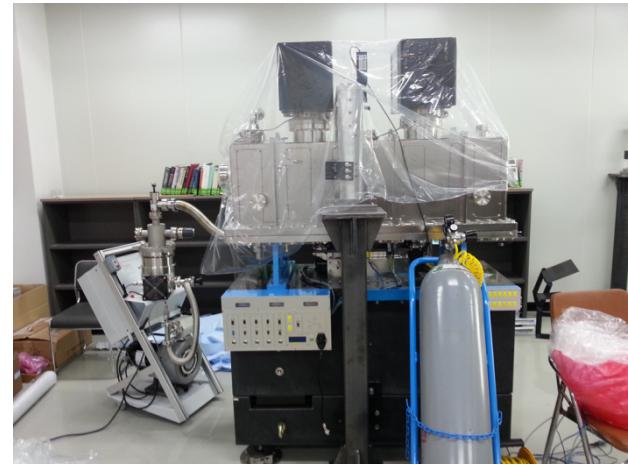
- Mirror acceptance: 600 -1000 mm mirror
- Resolution:  $\leq 0.05$  (beam rms = 1.4 μm)
- Stability:  $\leq 0.07$  / 8 hours (arcsec)
- Vacuum:  $<10^{-9}$  Torr (in operation:  $<10^{-6}$  Torr)

## ➤ Production

- Manipulator design: PAL staff (Hyo Yoon Kim)
- Mirror manipulator: Vactron (Korea)

## ➤ Manipulator inspection

| Motion                             | Parameter             | Specification   | Measurement                               | Judgment |
|------------------------------------|-----------------------|---|---|----------|
| Horizontal<br>(X-axis)             | Range (mm)            | $\pm 10$  | $\pm 10$                                  | OK       |
|                                    | E_Resolution (μm)     | $\leq 0.5$  | 0.05                                      | OK       |
|                                    | M_Resolution (μm)     | $\leq 0.05$   | 0.01                                      | OK       |
|                                    | Precision (μm)        | $\leq 2.0$  | 0.7                                       | OK       |
|                                    | Stability (μm)        | $\leq 3.0 / 8$ hours  | 1.9                                       | OK       |
| Vertical<br>(Y-axis)               | Range (mm)            | $\pm 10$  | +10,-15                                   | OK       |
|                                    | E_Resolution (μm)     | $\leq 0.2$  | 0.2                                       | OK       |
|                                    | M_Resolution (μm)     | $\leq 0.1$  | 0.08                                      | OK       |
|                                    | Precision (μm)        | $\leq 1.0$  | 0.3                                       | OK       |
|                                    | Stability (μm)        | $\leq 2.0 / 8$ hours  | 1.6                                       | OK       |
| Roll <sup>1</sup><br>(gonio axis)  | Range (Degree)        | $\pm 1.5$   | $\pm 1.5$                                 | OK       |
|                                    | E_Resolution (arcsec) | $\leq 0.4$  | 0.093                                     | OK       |
|                                    | M_Resolution (arcsec) | $\leq 0.1$  | 0.014                                     | OK       |
|                                    | Precision (arcsec)    | $\leq 2.0$  | 1.23                                      | OK       |
|                                    | Stability (arcsec)    | $\leq 1.0 / 8$ hours  | 0.2                                       | OK       |
| Pitch <sup>1</sup><br>(gonio axis) | Range (Degree)        | $\pm 1.5$<br>(linearly $\approx 8.86$ mm)                                     | $\pm 1.5$<br>(linearly $\approx 8.86$ mm) | OK       |
|                                    | E_Resolution (arcsec) | $\leq 0.05$<br>(beam 범위 = 10 μm)  | 0.028<br>(beam 범위 = 7 μm)                 | OK       |
|                                    | M_Resolution (arcsec) | $\leq 0.02$<br>(beam 범위 = 4 μm)   | 0.0006<br>(beam 범위 = 1.4 μm)              | OK       |
|                                    | Precision (arcsec)    | $\leq 0.2$<br>(beam 범위 = 20 μm)   | 0.17                                      | OK       |
|                                    | Stability (arcsec)    | $\leq 0.07 / 8$ hours   | 0.076                                     | OK       |
| Base<br>Alignment                  | Driver                | Manual  |   | OK       |
|                                    | Range                 | Z direction, $\pm 25$ mm<br>(with roll, pitch)<br>X, Y direction, $\pm 15$ mm | $\pm 25$ mm<br>$\pm 15$ mm                | OK       |



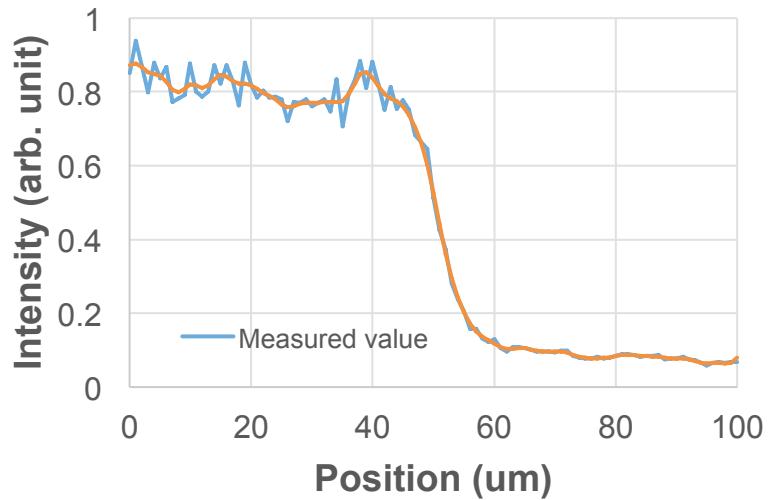
Motion & stability test at PAL-XFEL



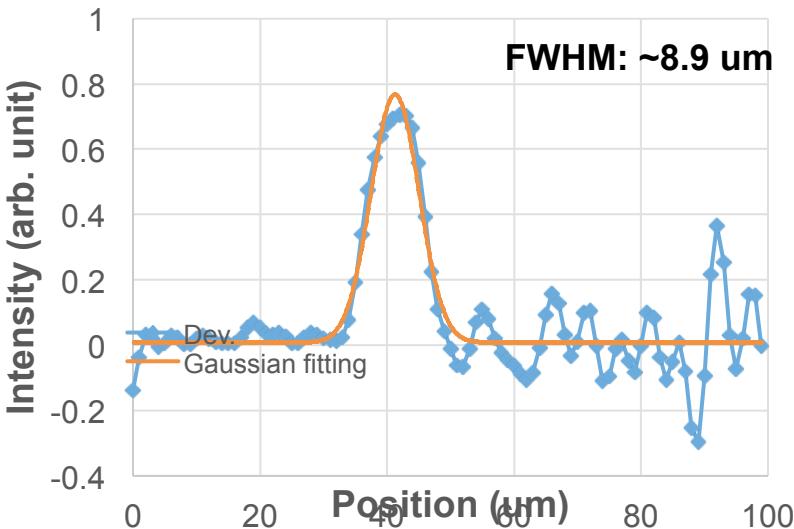
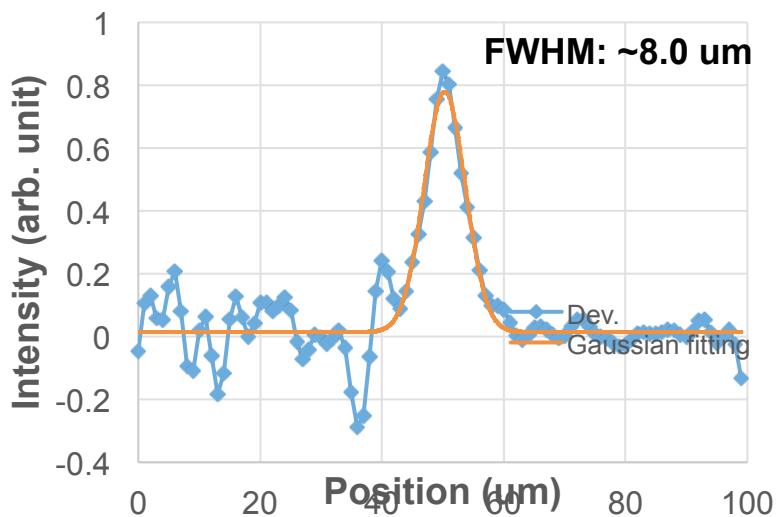
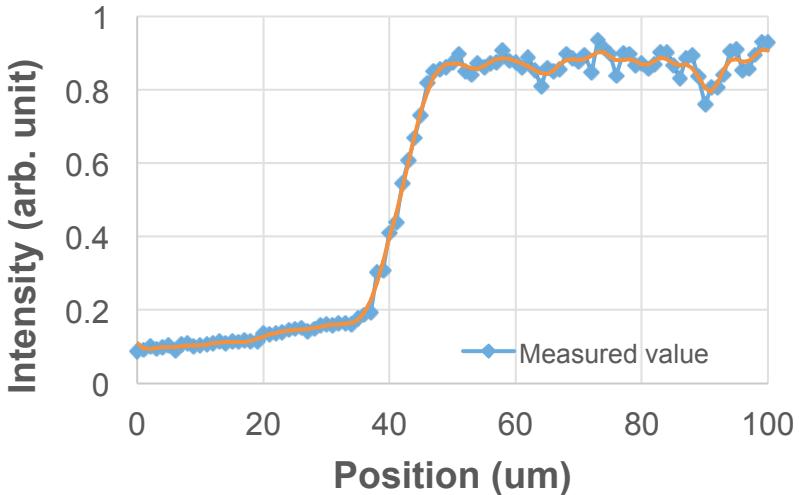
Mirror manipulator assemble at PAL-XFEL

# K-B mirror focusing @ NCI (6.1 keV)

## Vertical direction



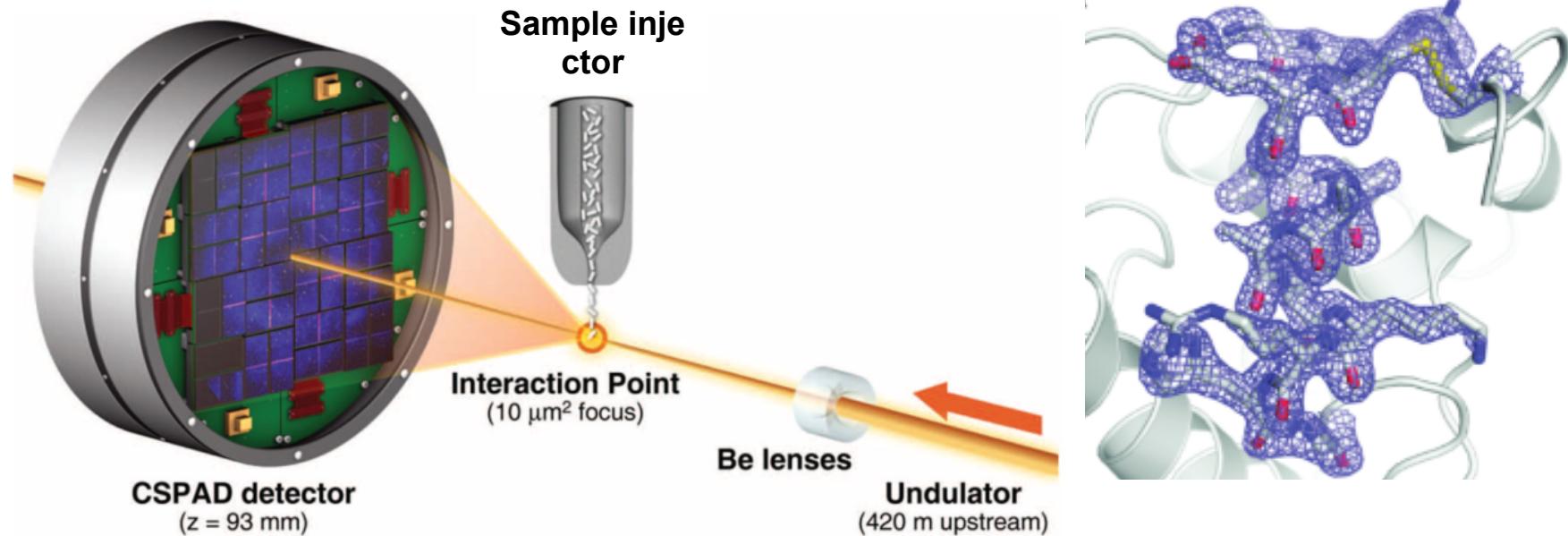
## Horizontal direction



# Serial femtosecond crystallography



## ➤ High resolution Protein Structure Determination



Experimental geometry for SFX

Boutet et al. Science (2012)

- All the nanocrystals possess the same crystal symmetry, a series of nanocrystals could be illuminated by FEL X-ray pulses and the diffraction patterns recorded.
- The variations in alignment of the crystal axes from sample to sample can be determined from the indexing of the Bragg peaks in the diffraction patterns.

# SFX experiments strategy



## Sample preparation

- Growing crystal
- Crystal quantity
- Buffer condition
- Size control

## Crystal analysis

- Real protein crystal?
- Proper size?
- Density control

## Experiment

- Buffer test
- Liquid jet injector
- LCP injector
- Dedicated chamber

**Users side**

## Structure analysis

- CrystFEL / cctbx.xfel
- Structure refinement

## Data treatment

- Hit rate, Completeness
- Background calibration
- Peak finding

## Data acquisition

- Large area detector: high resolution data
- Distance control: adapt for sample features

# HX beamline sample preparation room



Room166

SEM  
Nano particle characterization



## Hitachi Su8010

- Cold FE gun
- Semi-in-lens type
- High resolution image (1.0nm@15kV)
- Deceleration function (1.3nm@1.0kV)
- Dual SE detector ( Lower/Upper )
- EDS (Energy Dispersive Spectrometer)
- 3-axis goniometer stage
- Ion sputter with Pt target
- Consumable and spare parts

Room276



Long term bio sample preparation

Sample preparation

# Sample analysis instruments

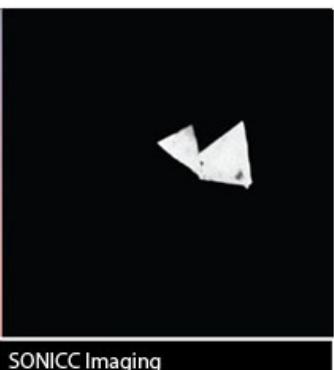


**SONICC** - sample observation  
(Second Order Non-linear Imaging of Chiral Crystals)

 **FORMULATRIX**  
Crystallization - Liquid Handling - dPCR



Visible Imaging

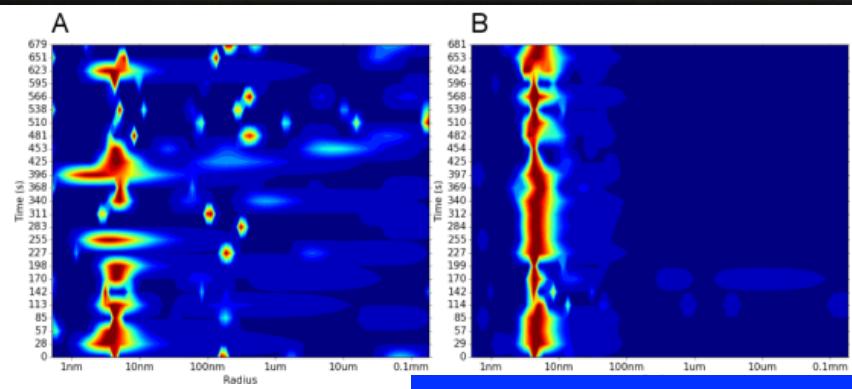
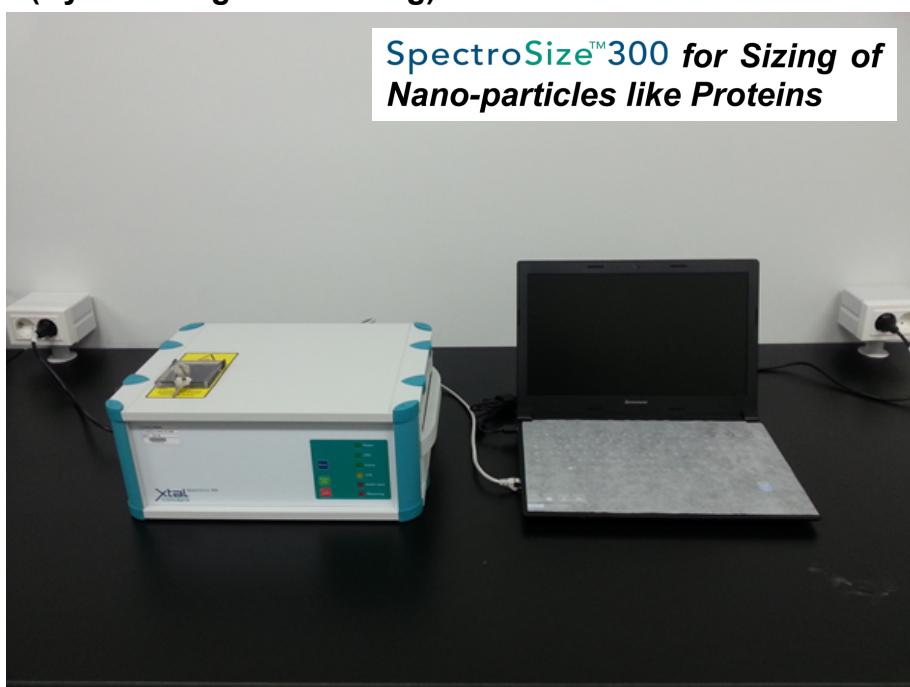


SONICC Imaging

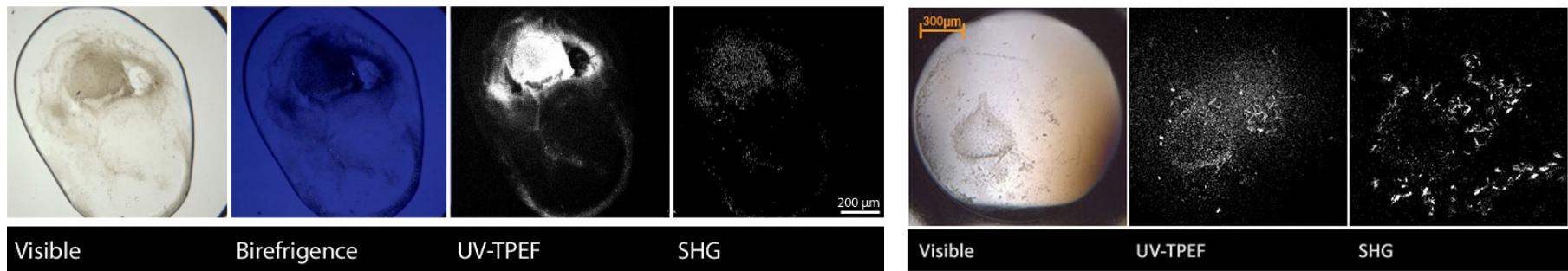
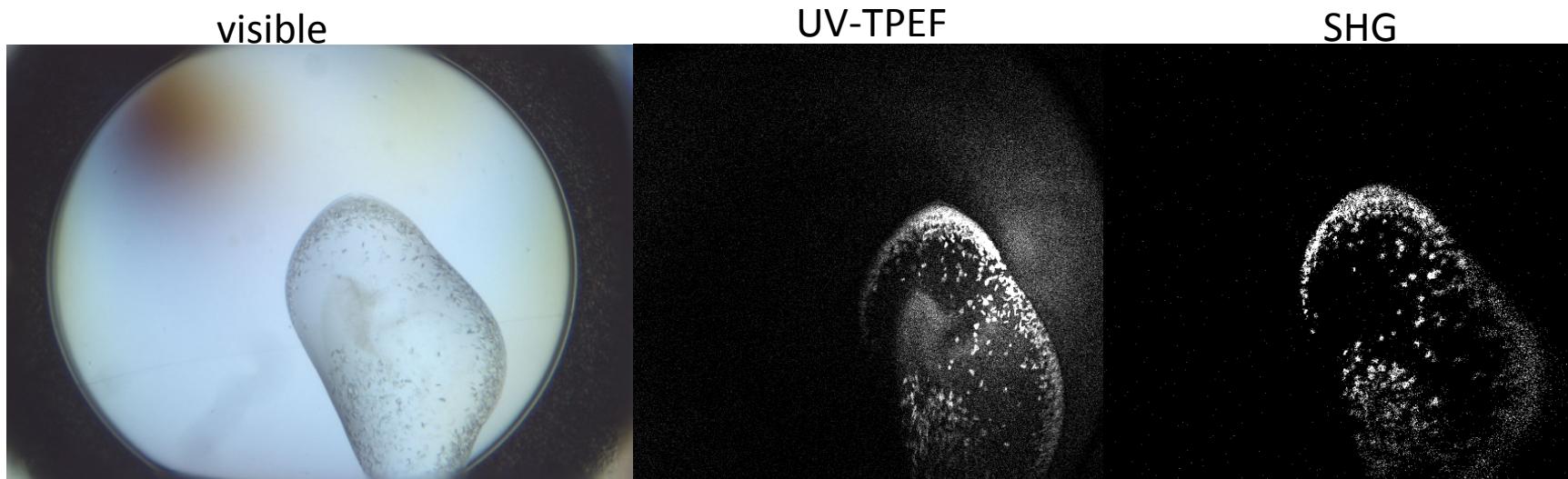
**DLS** - size determination  
(Dynamic Light Scattering)

Room161-1

**SpectroSize™ 300 for Sizing of Nano-particles like Proteins**

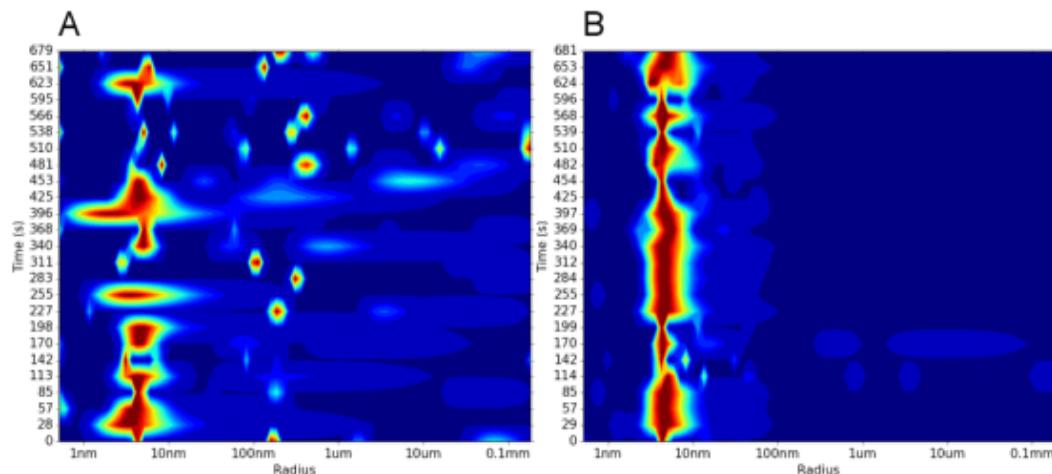


# Protein crystal detection - SONNIC



The combination of visible, UV-TPEF and SHG imaging make for a powerful tool for protein crystal imaging

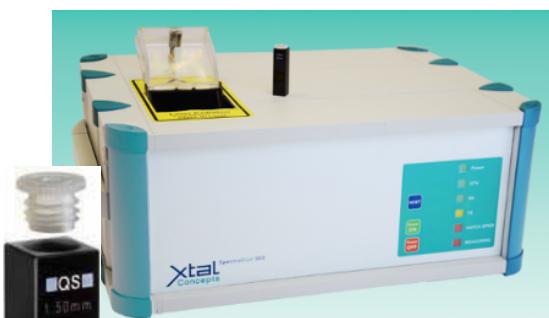
# Sample size characterization - DLS



*In situ* DLS in labbro plates. Radius distribution plot of a membrane protein detergent complex before gel filtration (A) and after gel filtration (B).



## SpectroSize™ 300 for Sizing of Nano-particles like Proteins



The minimum required sample volume is  $\sim 8 \mu\text{l}$ .

## SpectroSize™ 300 TECHNICAL DATA

### Laserdiode

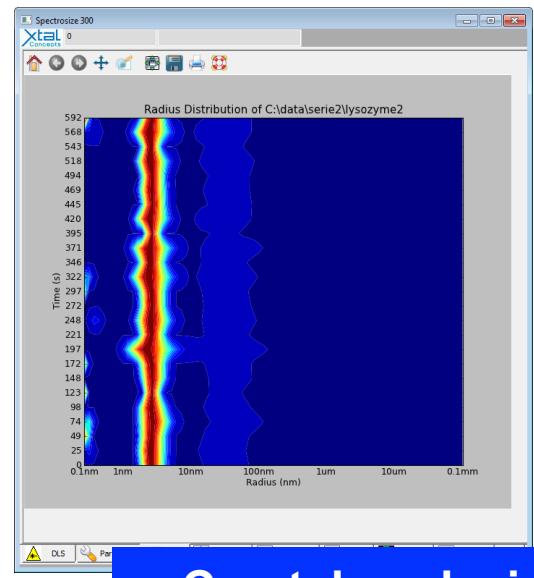
Temperature stabilized single-mode Laser diode  
✓ Wavelength: 660 nm  
✓ Optical power: 100 mW  
□ Wavelength: □ 785 nm □ 532 nm □ 405 nm

### Particle size

Measurement range  
✓ Minimum: 1 nm  
✓ Maximum: approx. 6  $\mu\text{m}$

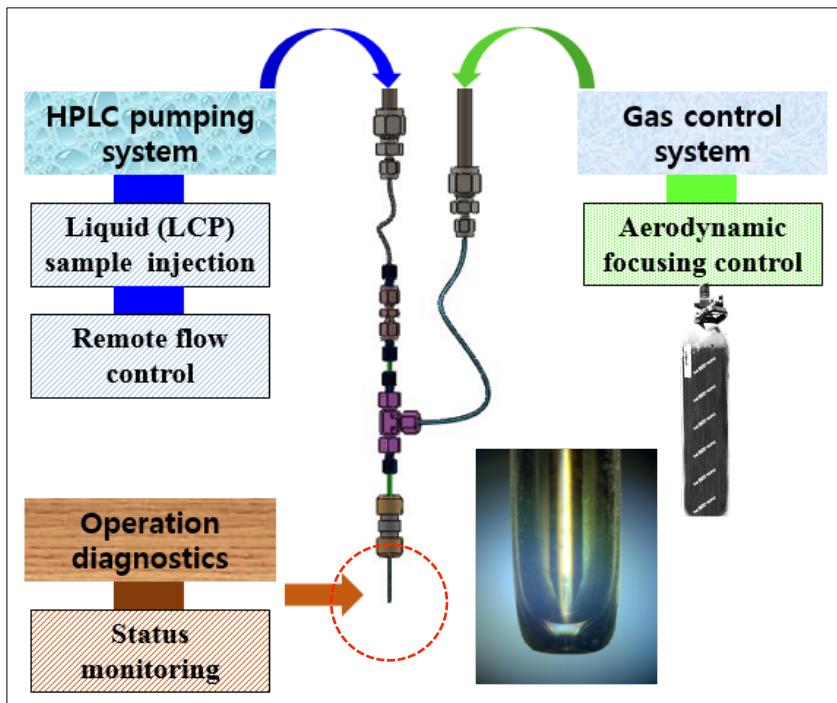
### Sensitivity

Sample concentration with standard laser (660 nm)  
✓ Minimum 0.1 mg/ml of lysozyme  
✓ Maximum > 100 mg/ml

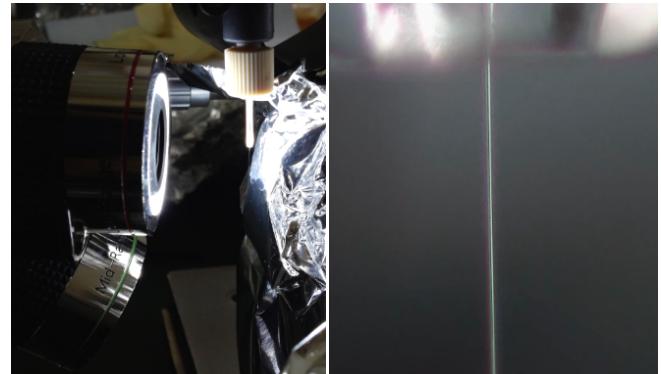


Crystal analysis

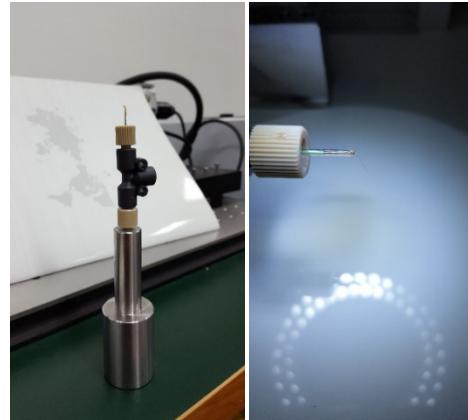
# Sample injectors for SFX



Liquid sample injector operation scheme



Liquid jet injector



LCP injector



## ➤ Liquid jet injector:

- Gas dynamic virtual nozzle (GDVN)
- Soluble protein crystals and nano particles

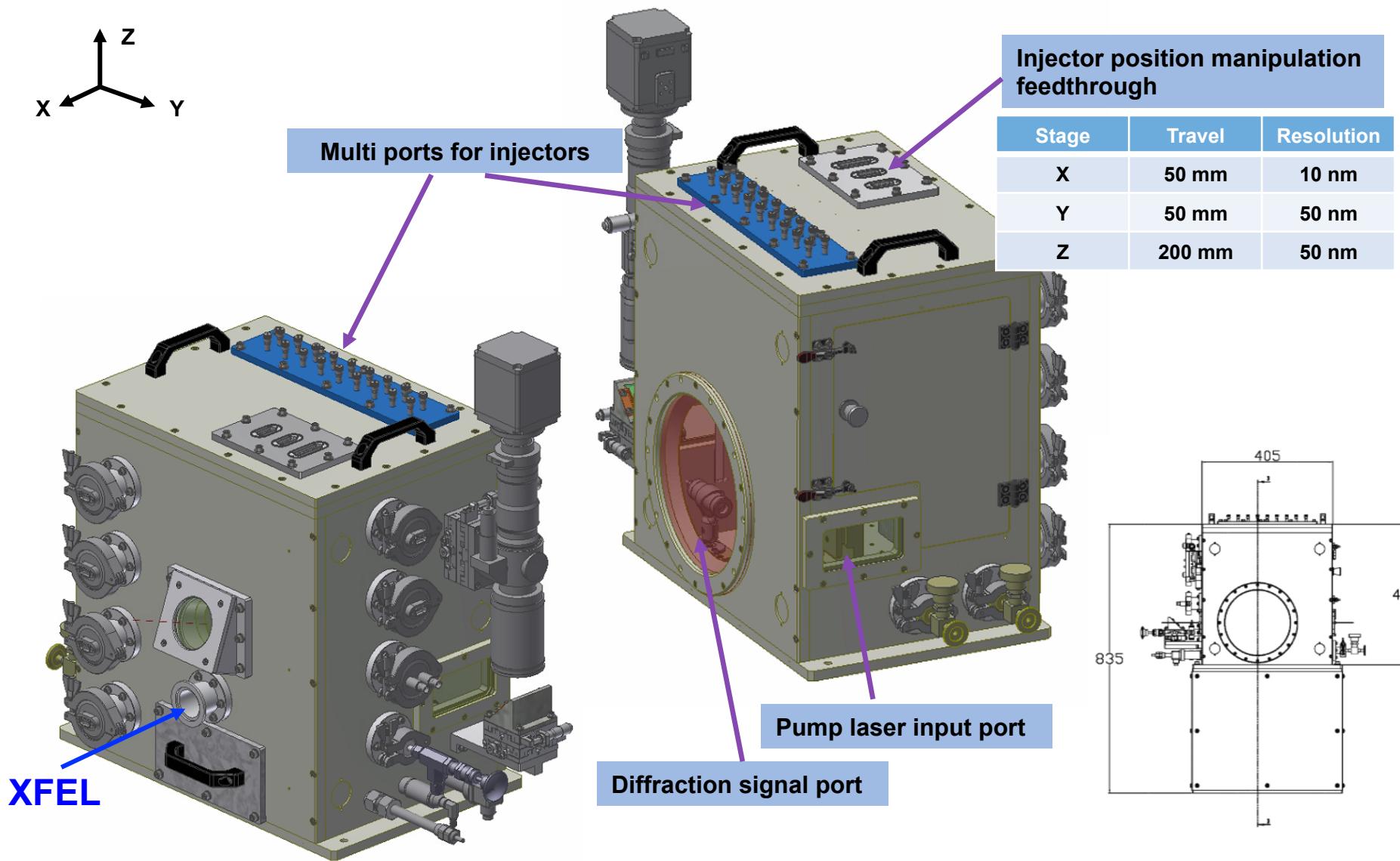
- Flow rate: 20 ~ 30  $\mu\text{l}/\text{min}$
- Diameter control: 3 ~ 30  $\mu\text{m}$

## ➤ LCP injector:

- Low sample consumption
- Membrane proteins & micro/nano crystals
- Operation time: 7 hours with 94  $\text{n}\mu\text{l}/\text{min}$

- Flow rate: 90 ~ 200  $\text{n}\mu\text{l}/\text{min}$
- Diameter: 50, 75, 100  $\mu\text{m}$
- Reservoir volume: 40  $\mu\text{l}$

# SFX dedicated chamber at PAL-XFEL



# SFX dedicated chamber at PAL-XFEL



## ➤ Sample delivery :

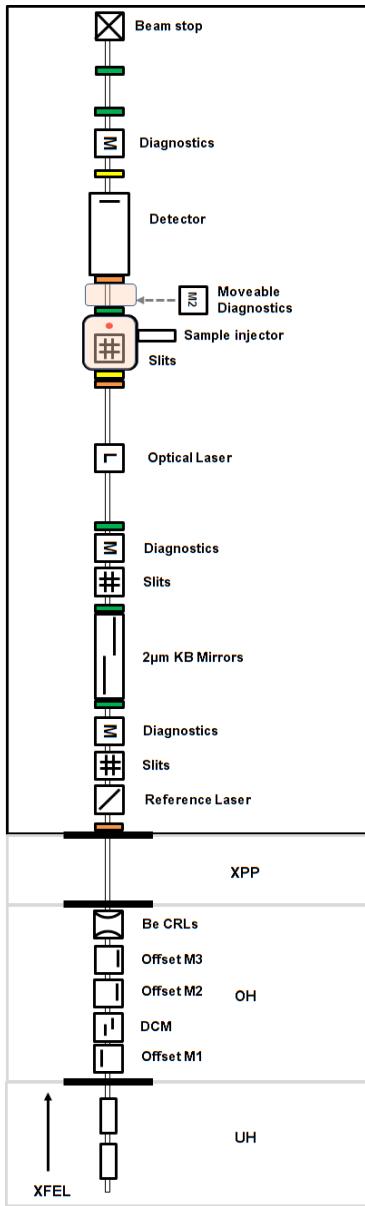
- Soluble samples (protein crystals, nano particles in solution)
- Samples in lipidic cubic phase (LCP)
- Carrier matrix with nano crystals
- Compatible with [Liquid jet injectors](#) (GDVN) & [LCP injectors](#)

## ➤ Chamber operation :

- In [helium](#) atmosphere
- [Multi port](#) injection
- Oxygen concentration sensor
- Injector diagnostics ports
- Pumping laser ports

Experiment

# Detectors

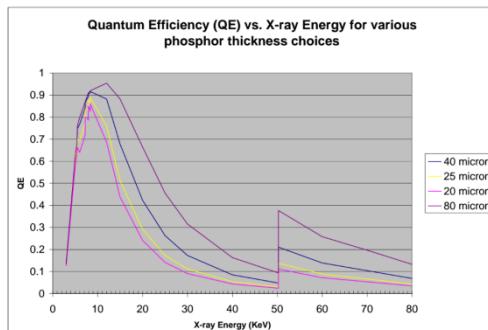
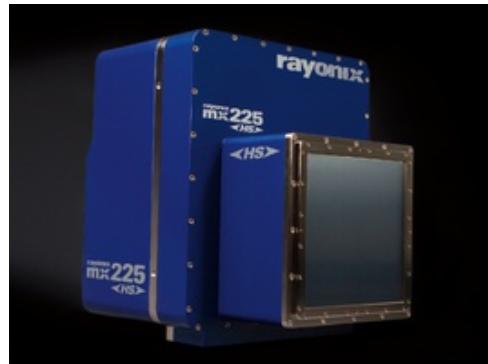


## ➤ Purpose

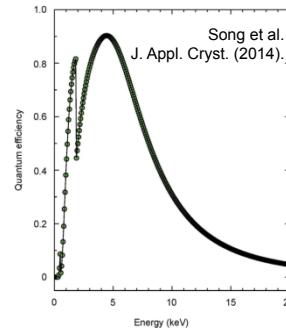
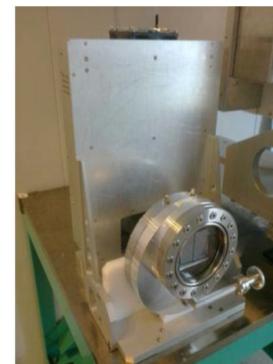
- Measure the 2D coherent diffraction patterns

## ➤ Requirements specification

- Energy range: 2-20 keV
- Quantum efficiency over at least 0.8
- Random noise of <0.18
- Detector size of > 20 cm
- Pixel size of < 30 - 50μm
- Dynamic range of > 10<sup>4</sup>
- Frame rate of 60 fps



MX225-HS



MPCCD

## MX225-HS

### On-chip Binning

|       |                 |                    |
|-------|-----------------|--------------------|
| 2 X 2 | Readout Speed   | 10 frames/second   |
|       | Pixel Size (μm) | 78μm               |
|       | Frame Size      | 2880 x 2880 pixels |
| 3 X 3 | Readout Speed   | 20 frames/second   |
|       | Pixel Size (μm) | 117μm              |
|       | Frame Size      | 1920 x 1920 pixels |
| 4 X 4 | Readout Speed   | 40 frames/second   |
|       | Pixel Size (μm) | 156μm              |
|       | Frame Size      | 1440 x 1440 pixels |

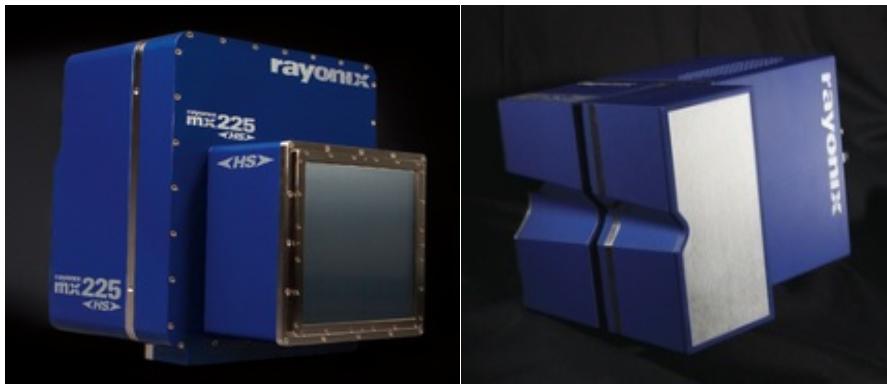
| Company/Institute              | PSI   |
|--------------------------------|---|
| Type                           | JUNGFRAU  |
|                                | 0.1   |
|                                | Hybrid-pixel (Integrating-Dynamic gain switching(3-fold)) |
| Energy range                   | >3keV   |
| ADC                            | 14bit   |
| Dynamic Range                  | >1:10 <sup>4</sup> @12keV                                 |
| Noise                          | <150 e <sup>-</sup>                                       |
| Frame Rate (Hz)                | 2kHz  |
| Pixel Size (μm)                | 75x75   |
| Active Area [mm <sup>2</sup> ] | 40x80   |
| System                         | (module)  |
| Status                         | Prototype   |

Basic Module  
75 μm x 75 μm  
512 x 1024 (0.5M)  
62.5kSF<sub>r</sub>.

JUNGFRAU (2018-2020)

Data acquisition

# Detectors for SFX



| Energy<br>(keV) | $\lambda$ (Å) | Crystal to detector distance (mm) |      |      |      |      |      |
|-----------------|---------------|-----------------------------------|------|------|------|------|------|
|                 |               | 75                                | 100  | 125  | 150  | 175  | 200  |
| 12.4            | 1.00          | 1.22                              | 1.58 | 1.4  | 1.58 | 1.77 | 1.97 |
| 11              | 1.13          | 1.19                              | 1.38 | 1.57 | 1.78 | 2    | 2.22 |
| 10              | 1.24          | 1.31                              | 1.51 | 1.73 | 1.96 | 2.2  | 2.45 |
| 9               | 1.38          | 1.46                              | 1.68 | 1.92 | 2.18 | 2.44 | 2.72 |
| 8               | 1.55          | 1.64                              | 1.89 | 2.16 | 2.45 | 2.75 | 3.06 |
| 7               | 1.77          | 1.88                              | 2.16 | 2.47 | 2.8  | 3.14 | 3.49 |
| 6               | 2.07          | 2.19                              | 2.52 | 2.88 | 3.27 | 3.67 | 4.08 |

Recordable structure resolution (Å)

Available resolution with MX225-HS

|                       | MX255-HS  | LX255-HS                               |
|-----------------------|---|--|
| Pixel Size            | 39 $\mu\text{m} \times 39 \mu\text{m}$                          | 44 $\mu\text{m} \times 44 \mu\text{m}$ |
| Pixel Number          | 5760 $\times$ 5760  | 1920 $\times$ 5760                     |
| Active Area           | 225 mm $\times$ 225 mm  | 85 mm $\times$ 225 mm                  |
| Operating Temperature |   | -80°C                                  |
| Quantum Efficiency    | <80% (Detected Quantum Effy.)<br>@ 8-12 keV                     |  |
| Noise                 | High Speed mode: 8 e-/ pixel<br>Low Noise mode: 4 e- / pixel    |  |
| Dynamic Range         | $\sim 10^4$ photons/ 2x2 pixels<br>with 12 keV X-ray            |  |
| Frame Rate            | 2.5 Hz (1x1) /<br>10 Hz (2x2: standard) /<br>40 Hz (4x4)        |  |
| PSF                   | 100 $\mu\text{m}$ FWHM<br>with 40 $\mu\text{m}$ thick. phosphor |  |

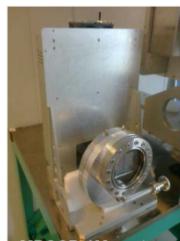
Data acquisition

# Detector stages

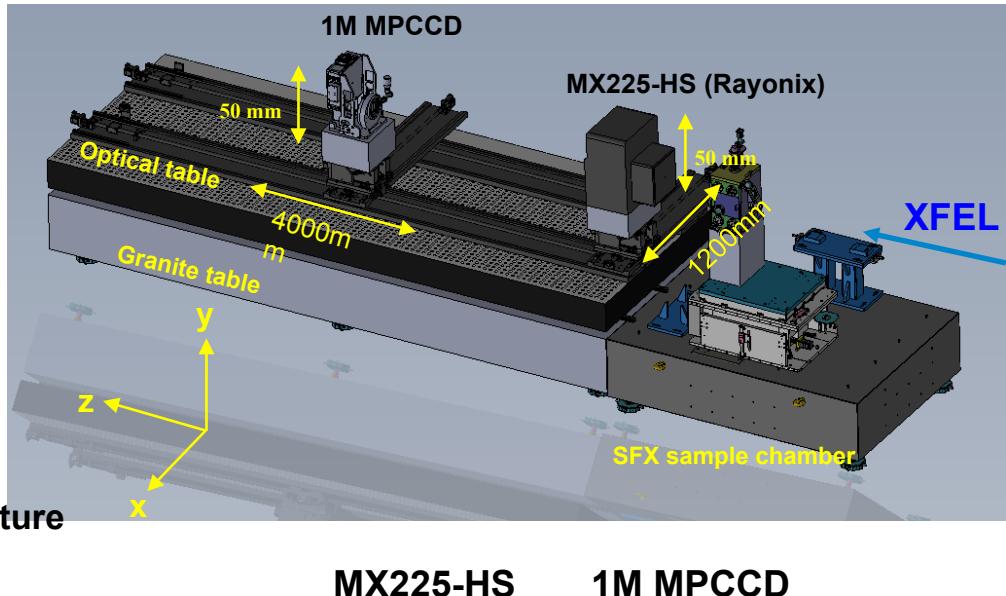
## 1) Detectors



MX225-HS (Rayonix)

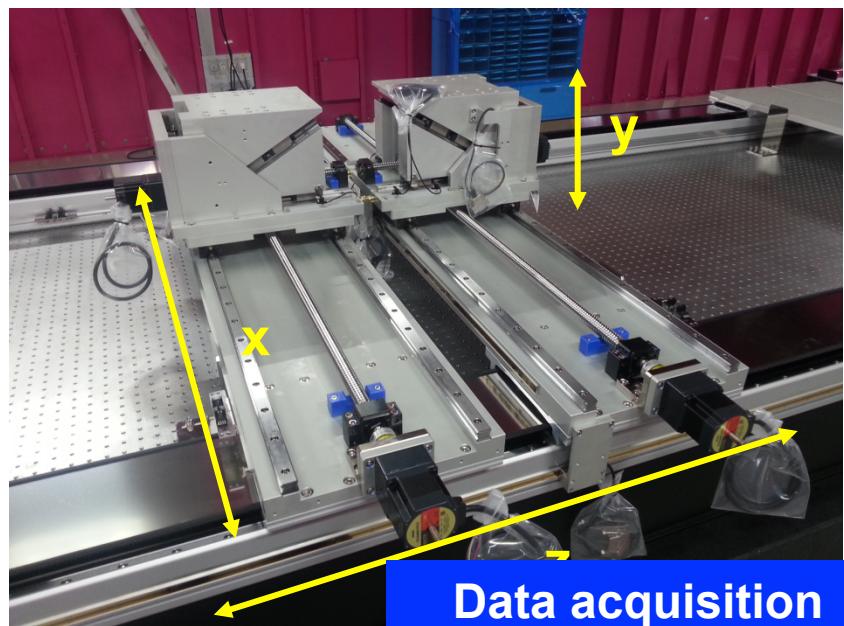
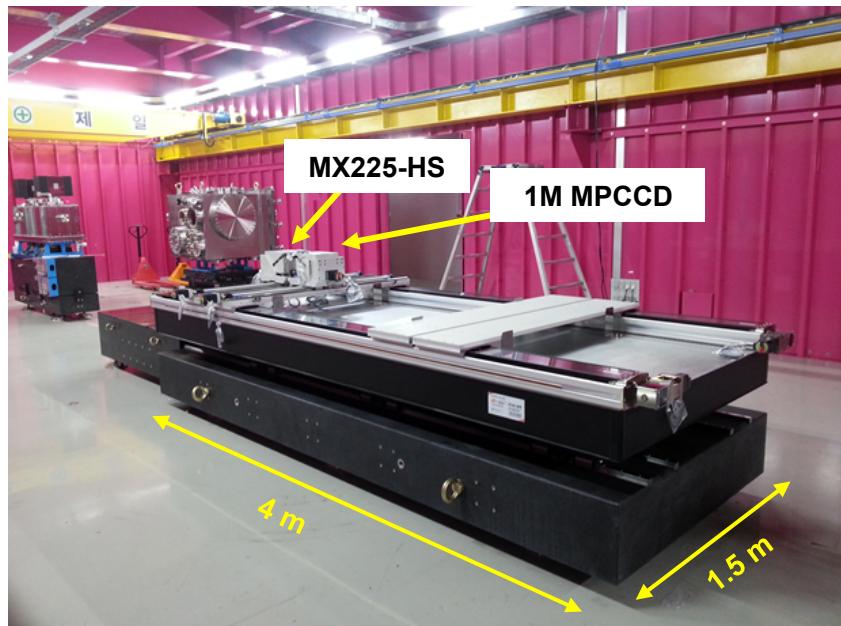


1M MPCCD



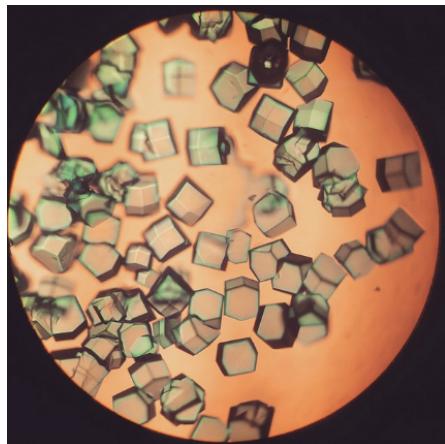
## 2) Detector distance manipulation

- Optimizing preferred resolution and peak separation depending on the crystal structure features

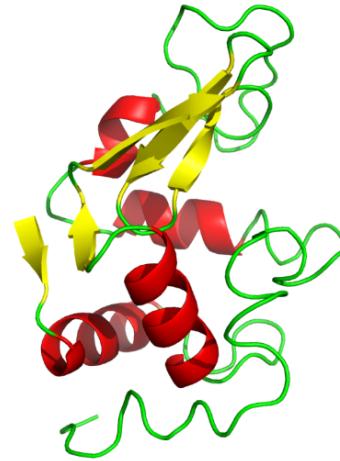


# Demo experiment

- Sample: Lysozyme microcrystals
- Purpose:
  - Instrument test (injector, sample chamber, detector...)
  - Alignment of the key features (sample-to-detector distance...)
  - Data processing
- Sample delivery method: Liquid jet sample injector, LCP injector
- Sample environment: He ambience



Lysozyme crystals



Crystal structure of Lysozyme (at PLS-II)

# Summary



SFX: High resolution structure analysis for protein crystals in perfectly hydrated state @ room temperature

- NCI: serial femtosecond crystallography & coherent diffraction imaging
- SFX: sample injectors (liquid jet & LCP) + dedicated chamber
- Liquid jet injector delivery: micro/nano sized crystal w/ buffer solutions
  - multi port injection : diverse sample loading w/o nozzle change
  - easy handling and maintenance
- LCP injector delivery: membrane proteins & nano/micro crystals in carrier matrix
  - low sample consumption
- Dedicated chamber: compatible w/ liquid jet & LCP injectors
  - operated in He gas environment
- Detector stage: convenient adjustment of sample-to-detector distance optimizing resolution and peak separation
- Demo experiment: Lysozyme microcrystals